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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit: **1792**

Serial No.: **10/576,193**

Examiner: **WALTERS JR, Robert S**

Filed: **April 17, 2006**

P.T.O. Confirmation No.: 8608

For. **METHOD OF FORMING LUSTER COATING FILM**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: March 17, 2010


Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated November 18, 2009, for one month, from February 18, 2010, to March 18, 2010.

The Commissioner is authorized to charge our Deposit Account in the amount of \$130.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP


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DAG/xl

Atty. Docket No. **060321**
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PATENT & TRADEMARK OFFICE
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